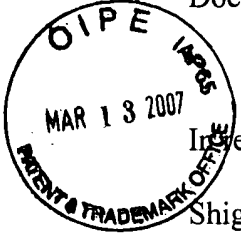


IFW

Docket No.: 070456-0153

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Inventive Application of

: Customer Number: 20277

Shigeya NARITSUKA, et al.

: Confirmation Number: Not Yet Assigned

Application No.: 10/594,742

: Group Art Unit: Not Yet Assigned

Filed: September 28, 2006

: Examiner: Not Yet Assigned

For: SEMICONDUCTOR LIGHT EMITTING DEVICE

CORRECTED INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. Please note that only the final U. S. Patent Document is being submitted for the first time, due to a typographical error in the original submission. The U.S. reference was incorrectly listed as US 6,335,549 B1 in the Information Disclosure Statement of September 28, 2006, but should have been listed as US 6,335,546 B1. Please replace the original form PTO-1449 with the attached corrected PTO-1449.

It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement was originally filed with the application and no certification or fee is required. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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Date: March 13, 2007

**Please recognize our Customer No. 20277
as our correspondence address.**

INFORMATION DISCLOSURE
CITATION IN AN
APPLICATION

ATTY. DOCKET NO.
070456-0153

SERIAL NO.
10/594,742

APPLICANT
Shigeya NARITSUKA, et al.

FILING DATE
**September 28,
2006**

GROUP
Not Yet Assigned

(CORRECTED PTO-1449)

U.S. PATENT DOCUMENTS

CITE NO.	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	US 6,620,641 B2	09/16/2003	Yamaguchi et al.	
	US 6,649,942 B2	11/18/2003	Hata et al.	
	US 2001/0004112 A1	06/21/2001	Furukawa et al.	Corresponds to EP 1 111 689 A2
	US 2003/0062531 A1	04/03/2003	Furukawa et al.	Corresponds to EP 1 111 689 A2
	US 2004/0079955 A1	04/29/2004	Furukawa et al.	Corresponds to EP 1 111 689 A2
	US 6,335,546 B1	01/01/2002	Tsuda et al.	

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes -Number 4 -Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation	
						Yes	No
		JP 03-133182	06/06/1991	SHOWA DENKO KK		JAPAN (w/ English Abstract)	
		JP 2002-246279	08/30/2002	CANON INC		JAPAN (w/ English Abstract)	
		EP 1 111 689 A2	06/27/2001	TOSHIBA CORPORATION	Corresponds to US 2001/0004112 A1, US 2003/0062531 A1, and 2004/0079955 A1	JAPAN (w/ English Abstract)	
		JP 06-302857	10/28/1994	HEWLETT PACKARD CO		JAPAN (w/ English Abstract)	
		JP 2001-291895	10/19/2001	SHARP CORP		JAPAN (w/ English Abstract)	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
		Zhang, S., et al. "LPE Lateral Overgrowth of GaP" Japanese Journal of Applied Physics, March 1990, Vol. 29, No. 3, pp. 545-550.

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

